

35.C15462



PATENT APPLICATION

2812  
#6/105  
12-3-01  
R&M

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RECEIVED  
TECHNOLOGY CENTER 2200  
NOV -5 2001

In re Application of: ) Examiner: Not Yet Assigned  
KIYOTAKA WASA ET AL. ) Group Art Unit: 2812  
Application No.: 09/880,757 )  
Filed: June 15, 2001 )  
For: STRUCTURE OF )  
PIEZOELECTRIC ELEMENT )  
AND LIQUID DISCHARGE )  
RECORDING HEAD, AND )  
METHOD OF MANUFACTURE )  
THEREOF ) October 31, 2001

Commissioner for Patents  
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

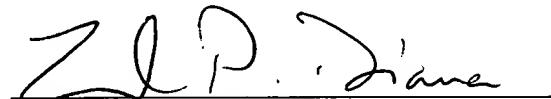
Among the listed documents, the Japanese article, "Sputtering Technologies", is discussed in the specification at page 4, and the Examiner is directed thereto for the concise explanation of relevance of this non-English document. The other listed documents were cited in an August 31, 2001 European search report, a copy of which is also enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
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Attorney for Applicants

Registration No. 79,296

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